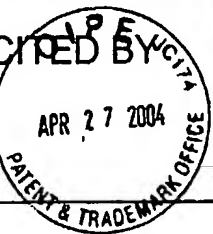


12/05/01

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<b>LIST OF PRIOR ART CITED BY CITA</b> <b>APPLICANT</b> <b>(PTO-1449)</b>				ATTY. DOCKET NO. P-0311		APPLN. SERIAL NO. 10/002,404	
				APPLICANT(S) Hyun Duk CHO; Sung Deuk KIM			
				FILING DATE December 5, 2001		GROUP 2613	



U.S. PATENT DOCUMENTS						
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U.S. PATENT APPLICATION PUBLICATIONS						
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	
B.	20030128755	7/10/2003	Jiangtao WEN (related to CN 1238644A listed below)			

U.S. PATENT APPLICATIONS						
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FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
B.	1238644 A	12/1/98	CHINA			X	
B.	1263422 A	11/2/99	CHINA			PART. ABST.	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)	

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